



Attorney Docket No. 0756-7263

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Shunpei YAMAZAKI et al.

Serial No. 10/799,626

Filed: March 15, 2004

For: LASER IRRADIATION APPARATUS,  
LASER IRRADIATION METHOD,  
AND METHOD FOR  
MANUFACTURING A  
SEMICONDUCTOR DEVICE

) Group Art Unit: 2813

) Examiner: Laura Schillinger

) CERTIFICATE OF MAILING

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) Adrian Stamper

)

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RESPONSE

Honorable Commissioner of Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

The Official Action mailed January 4, 2007, has been received and its contents carefully noted. This response is filed within three months of the mailing date of the Official Action and therefore is believed to be timely without extension of time. Filed concurrently herewith is a *Request for Continued Examination*. Accordingly, the Applicant respectfully submits that this response is being timely filed.

The Applicant notes with appreciation the consideration of the Information Disclosure Statements filed on March 15, 2004; September 27, 2005; and March 2, 2006.

A further Information Disclosure Statement is submitted herewith and consideration of this Information Disclosure Statement is respectfully requested.

Claims 1-15, 17-42, 44-46, 48 and 50-55 are pending in the present application. Claims 1-10, 12-14, 19-42, 44-46, 48 and 50-55 have been withdrawn from consideration by the Examiner. (Although the Office Action Summary shows that claims